## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Thomas Mueller

Art Unit : Unknown

Serial No.: N/A

Examiner: Unknown

Filed

: Herewith

Title

: METHOD FOR CALIBRATION OF A PHOTODIODE, SEMICONDUCTOR

CHIP AND OPERATING METHOD

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

## INFORMATION DISCLOSURE STATEMENT

Applicant requests consideration of the references listed on the attached PTO-1449 form. Under 37 C.F.R. § 1.98 (a)(2)(ii), only copies of foreign patent documents and/or non-patent literature are enclosed. Copies of any listed U.S. patents or U.S. patent application publications can be provided upon request.

This statement is being filed with the application. Please apply any charges or credits to Deposit Account No. 06-1050.

Respectfully submitted,

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U.S. Department of Commerce Patent and Trademark Office Attorney's Docket No. 14603-012US1

APIGUS 526097

## Information Disclosure Statement by Applicant

(Use several sheets if necessary)

Applicant
Thomas Mueller

Filing Date

Group Art Unit

(37 CFR §1.98(b))

U.S. Patent Documents							
Examiner Initial	Desig. ID	Document Number	Publication Date	Patentee	Class	Subclass	Filing Date If Appropriate
	AA	4,131,488	12/26/1978	Israel A. Lesk et al.			
	AB	5,844,928	12/01/1998	Kalpendu R. Shastri et al			
-	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						

Foreign Patent Documents or Published Foreign Patent Applications								
Examiner	Desig.	Document	Publication	Country or			Translation	
Initial	ID	Number	Date	Patent Office	Class	Subclass	Yes	No
	AL	09045744	02/14/97	Japan (Abstract only)				
	AM	05218327	08/27/93	Japan (Abstract only)				
	AN	02105078	04/17/90	Japan (Abstract only)				
	AO	62017621	01/26/87	Japan (Abstract only)				
	AP	62274234	11/28/87	Japan (Abstract only)				
	AQ	WO97/24728	07/10/97	WIPO				
	AR	WO01/86723	11/15/01	WIPO				
	AS	199 62 938	07/19/01	Germany			Abstract	
	AT	29 04 984	05/13/82	Germany			Abstract	

Other Documents (include Author, Title, Date, and Place of Publication)						
Examiner	Desig.					
Initial	ID	Document				
	AU					

Examiner Signature	

Date Considered

EXAMINER: Initials citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.